## **Acknowledgments**

The authors would like to thank the Technological Campus of the University of Navarra (TECNUN), Centro de Estudios e Investigaciones Técnicas (CEIT), and everybody at the COMMIC group (www.ceit.es/electrocom/RF/) for making possible this book's research. They also wish to express their gratitude to the Spanish government's Centro Para el Desarrollo Tecnológico Industrial (CDTI) office, the Basque government's Departamento de Industria, and the companies INCIDE S.A. and Owasys S.L.L. for their financial support. They would also like to thank Haymar Mancisidor for his invaluable help with the artwork and Marc Oakley for his editing work and valuable comments about the language of this book. The authors are very grateful to the McGraw-Hill team, not only for the chance to have this book published but for contributing to its development.

Finally, the authors thank their families for their support and patience. Without it this book would not have been possible.